



AMAT Docket No. 2616 US/RTP/LE
BSTZ Docket No. 004887.P090

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Guangcai Xing, et al.

Application No. 09/298,064

Filed: April 22, 1999

For: APPARATUS AND METHOD FOR EXPOSING A
SUBSTRATE TO PLASMA RADICALS

Examiner: Zervigon, R.

Art Unit: 1763

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Pursuant to Rule 1.97(d), Applicants desire to make of record the reference set forth on the attached form PTO/SB/08A. A copy of the reference is submitted herewith. A payment of a fee of \$180 as set forth in 37 CFR §1.17(p) is enclosed.

It is hereby certified that this Information Disclosure Statement is being filed after the mailing date of a final action. No item of information contained in the attached form was known to any individual designated in 37 CFR §1.56(c) more than three (3) months prior to the filing of this statement. In the event any petition is needed for consideration of this Information Disclosure Statement, Applicant hereby so petitions. Please charge any additional fee due to Deposit Account 02-2666. A duplicate of the fee transmittal sheet is enclosed for charging purposes.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN

Date: 1/3/01

By: William T. Babbitt
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231 on January 3, 2002.

1/3/2002

Nedy Calderon

Date